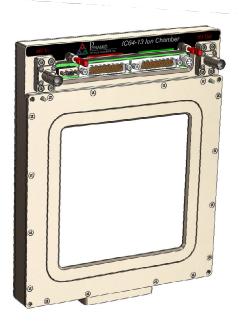
## Datasheet

## High-Resolution Single Axis Position Sensing Transmission Ionization Chamber with Integral Plane

#### Features

- 12.8 cm x 12.8 cm sensitive area
- Ionization chamber with 64 strip readout for position and shape monitoring in one axis
- Integral plane electrode for total beam current measurement
- Minimum scattering due to thin films of low-Z material
- Small beamline length (22 mm)
- Small electrode gaps for low recombination
- Polyimide film electrode substrates for radiation hardness
- Gold plated foil for readout electrodes for extended lifetime (revision B and later)
- Electrode patterns laser-cut for high geometric precision
- Operable with atmospheric pressure air chamber gas or flow-through gas
- Integrated temperature, pressure and humidity sensing
- Integrated desiccant for fill gas

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Applications	<ul> <li>Particle therapy beam monitoring</li> <li>On-line beam trajectory monitoring</li> <li>General high energy ion beam diagnostics</li> </ul>
Options	Non-multiplexed environmental sensor signals.

#### Specifications

<b>D</b>	
Beam compatibility	
Species	Protons, deuterons, fully-stripped carbon
Energy range	30 MeV/nucleon to 500 MeV / nucleon
Beam current density range	Up to 20 nA cm <sup>-2</sup> (particle current)
Sensor	
Туре	Parallel plate dual ionization chamber with multi-strip cathode and integral plane cathode.
High voltage	500-1000 V nominal (1300 to 2600 V cm <sup>-1</sup> ); maximum 1500 V
Sensitive area	128 mm by 128 mm

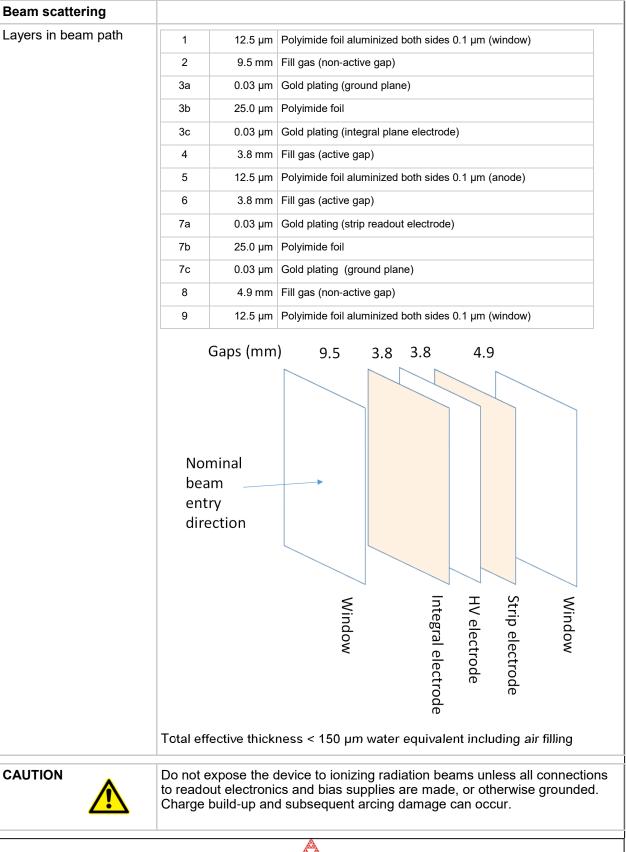


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Sensor (cont)					
Sensitive volume	Active volume 1: Integral cathode to anode. 3.8 mm spacing. Active volume 2: Anode to strip cathode. 3.8 mm spacing.				
Strip geometry	64 strips 2.00 mm pitch (50 μm inter-strip gaps typical)				
Gain uniformity	Better than +/-2% for beams within the sensitive area.				
Position accuracy	Integral linearity better than 50 $\mu m$ maximum deviation relative over the sen-				
Position resolution	Depends on signal to noise ratio; 10's of $\mu m$ achievable provided beam covers more than one strip.				
Fiducials	Electrode strips tolerance build-up relative to fiducial features on body +/- mm nominal, < +/- 0.1 mm typical .				
Chamber gas					
Operating gas	Dry atmospheric air, or flow of any clean ionization chamber gas (Ar/CO <sub>2</sub> , N <sub>2</sub> etc)				
Flow gas connections	To suit 1/8" (3.18 mm) tube push fit				
Desiccant	Desiccant sachet. Sachet can be changed with chamber in situ.				
Mechanical					
Insertion length	22 mm window to window, 28.4 mm housing face to face.				
Overall size	208 mm by 262 mm by 52 mm approx (see figures)				
Weight	1.3 kg ( 2.9 lb) excluding any added mounting brackets.				
Operating environment	Clean and dust-free, 0 to 35 C (15 to 25 C recommended , < 70% humidity, non-condensing, vibration < 0.1g all axes (1 to 50 Hz) Temperature and pressure compensation of chamber gain must be performed.				
Shipping and storage environment	-10 to 50 C, < 80% humidity, non-condensing, vibration < 1g all axes, 1 to 20 Hz				
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Connectors													
Strip readout		DSub male high density 44 pin.											
	Two identical connectors for channels 1-32 and 33-64												
	1	Strip 29 (61)	16	Strip 31 (63)	31	Strip 32 (64)							
	2	Strip 28 (60)	17	Strip 30 (62)	32	Chassis							
	3	Strip 26 (58)	18	Strip 27 (59)	33	AGnd / KGnd							
	4	Strip 24 (56)	19	Strip 25 (57)	34	AGnd / KGnd							
	5	Strip 22 (54)	20	Strip 23 (55)	35	AGnd / KGnd							
	6	Strip 20 (52)	21	Strip 21 (53)	36	AGnd / KGnd							
	7	Strip 18 (50)	22	Strip 19 (51)	37	AGnd / KGnd							
	8	Strip 16 (48)	23	Strip 17 (49)	38	AGnd / KGnd							
	9	Strip 14 (46)	24	Strip 15 (47)	39	AGnd / KGnd							
	10	Strip 12 (44)	25	Strip 13 (45)	40	AGnd / KGnd							
	11	Strip 10 (42)	26	Strip 11 (43)	41	AGnd / KGnd							
	12	Strip 8 (40)	27	Strip 9 (41)	42	AGnd / KGnd							
	13	Strip 6 (38)	28	Strip 7 (39)	43	Chassis							
	14	Strip 4 (36)	29	Strip 5 (37)	44	Strip 3 (35)							
	15	Strip 2 (34)	30	Strip 1 (33)	-	-							
Integral plane	nection t	arrangement is c to an I6400 electr 3.304 four-pin fer	rometer		in (M-F	) 44-way cable co							
		1 Integral	plane signal										
		2 AGnd											
		3 n/c											
		4 Chassis											
						SHV							
HV in													

# Datasheet

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Connectors (cont)							
Monitor (default_multiplexed)	Micro DSub male 9-pin						
(default, multiplexed)	1	1 Chassis			Analog out +		
	2	2 Analog out -			Signal select bit 0		
	3	Signal select bit 1		8	Device ID2		
	4	Device ID1		9	+5V in		
	5 DGnd						
Readout MUX			n (TTL levels) to onitor connecto		t analog sensor voltage that is ult option)	switche	
	E	Bit 1 Bit 0 S		Selec	Selected sensor		
		0	0	Temp	perature (V <sub>measT</sub> )		
		0	1	Press	sure (V <sub>measP</sub> )		
		1	0	Relat	ive humidity (V <sub>measH</sub> )		
		1	1	Refer	ence voltage (V <sub>ref</sub> )		
Monitor	-NMX purchase option - direct signals, no multiplex						
(-NMX option)	1	1 Chassis			Relative humidity (V <sub>measH</sub> )		
	2	Pressure (V <sub>measP</sub> )			+5 V in		
	3	Temperature (V <sub>measT</sub> )		8	Device ID2		
	4	Device ID1		9	+5 V in		
	5	DGnd					
Temperature	Temperature(centigrade) = 100*V <sub>measT</sub> Temperature(Kelvin) = Temperature(centigrade) + 273.2						
Pressure	Pressur	$\begin{array}{llllllllllllllllllllllllllllllllllll$					
Humidity	Relative	Relative humidity (%) = 157 * ( $V_{measH} / V_{ref}$ ) - 23.8					
Gain correction	Nominal gain at standard ambient temperature and pressure (Temperature <sub>SATP</sub> = 298.15 K, Pressure <sub>SATP</sub> = 100000 Pa), must be corrected for measured temperature and pressure:						
	Gain = Gain <sub>SATP</sub> / [ (Pressure <sub>SATP</sub> / Pressure(Pa) ) *(Temperature(Kelvin) / Temperature <sub>SATP</sub> ) ]						
	For nominal gains established at other reference temperature and pressure, substitute the appropriate reference values in the equation.						
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